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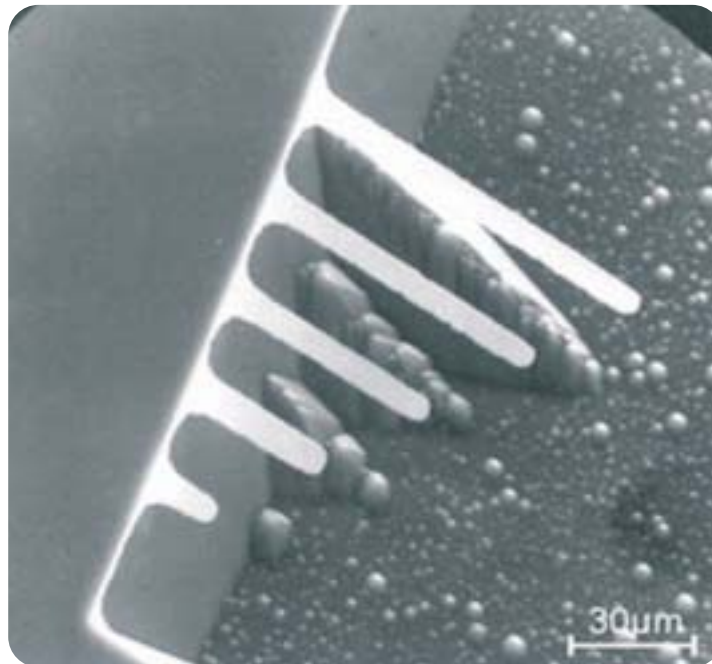
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Cantilever microstructures

*Aluminum cantilevers (fabricated by underetching method)
100 μm long, 10 μm wide, 0,45 μm thick*



University of Ljubljana,
Faculty of Electrical Engineering, Laboratory of Microsensor
Structures and Electronics

Edited by:
National Institute for Research and Development in Microtechnologies
(IMT-Bucharest, www.imt.ro)
Ministry of Education and Research, Romania

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